

INFORMATION DISCLOSURE CITATION
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Docket Number (Optional)
YPL-0073

Application Number
10/765,366

Applicant(s)
Sun-hee Kim, et al.

Filing Date
1-27-2004

Group Art Unit
NYA

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AB		6,156,389	12-5-2000	Brown, et al.	427	393.4	12-28-1998
AB		6,261,431 B1	7-17-2001	Mathies, et al.	204	601	12-28-1998
AB		6,475,722 B1	11-5-2002	Henck	435	6	11-16-1998

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

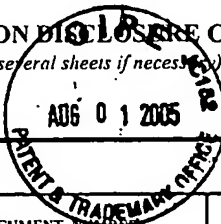
AB		"Chip PCR. 1. Surface passivation of microfabricated silicon-glass chips for PCR"; Authors: Mann A. Shoffner, Jing Cheng, Georgi E. Hvizia, Larry J. Kricka and Peter Wilding; Nucleic Acids Research, Vol. 24, No. 2; Oxford University Press; 1996; Pgs. 375-379
AB		"Miniaturized flow-through PCR with different template types in a silicon chip thermocycler"; Authors: Ivonne SchneegaB, Reiner Brautigamb and Johann Michael Kohler; LAB ON A CHIP, Vol. 1; The Royal Society of Chemistry; 2001; Pgs. 42-49

EXAMINER /Angela Bertagna/

DATE CONSIDERED 09/26/2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Docket Number (Optional) YPL-0073		Application Number 10/765,366
Applicant(s) Sun-hee Kim, et al.		
Filing Date 1-27-2004	Group Art Unit 1637	

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AB		6,277,480 B1	8-21-2001	Veerasamy, et al.	428	217	9-7-2000

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AB		2002/0050456 A1	5-2-2002	Sheppard, JR., et . al	204	451	5-15-2001

FOREIGN PATENT DOCUMENTS

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							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AB		"Fluoroalkylsilane Monolayers Formed by Chemical Vapor Surface Modification on Hydroxylated Oxide Surfaces"; Authors: Atsushi Hozumi, Kazuya Ushiyama, Hiroyuki Sugimura and Osamu Takai; XP8003176; American Chemical Society; Langmuir, Vol. 15, No. 22, 1999; Pgs. 7600 - 7604
AB		European Search Report; Application No. 04001605.5-1215-; Date of Completion: June 1, 2005

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